

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/820,575
 Filing Date April 7, 2004
 Inventor.....Scott E. Moore et al.
 Assignee..... Micron Technology, Inc.
 Group Art Unit.....2886
 Examiner Roy Punnoose
 Attorney's Docket No.MI22-2493
 Title: Semiconductor Workpiece Processing Methods and Turbidity Monitoring
 Methods

RESPONSE TO OCTOBER 15, 2008 OFFICE ACTION

To: Commissioner for Patents
 P.O. Box 1450
 Alexandria VA 22313-1450

From: James D. Shaurette (Tel. 509-624-4276; Fax 509-838-3424)
 Wells, St. John, P.S.
 601 W. First Avenue, Suite 1300
 Spokane, WA 99201-3828

Sir:

This is a response to the Office Action dated October 15, 2008, Applicants
 amend and remark as follows:

AMENDMENTS

Please enter this amendment (received on
 12/15/2008) .

/Roy M. Punnoose/